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Docket No.: 1806.1010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Takaaki MIYOSHI et al.

Serial No. 10/553,209

Group Art Unit: 1796

Confirmation No: 1241

Filed: October 13, 2005

Examiner: WOODWARD, ANA LUCRECIA

For: SHAPED RESIN ARTICLE AND CONDUCTIVE RESIN COMPOSITION

REQUEST FOR CONSIDERATION OF REFERENCE CITED ON PREVIOUSLY FILED INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

On February 3, 2006, applicants filed an Information Disclosure Statement ("IDS"). The IDS cited U.S. 2003/0116757 as reference AB and cited WO 01081473 as reference AF. As described in attachment 1(e), reference AB is an English language counterpart of reference AF. Enclosed are an additional copy of reference AF and the first page of reference AB.

The Examiner has considered reference AB, but not reference AF. This appears to be a simple oversight. However, since reference AF is cited in the international search report and may have an earlier prior art data than reference AB, applicants respectfully request the Examiner to formally acknowledge that the subject matter of reference AF has been considered. For the Examiner's convenience, an additional copy of form PTO-1449 is enclosed herewith. The Examiner is requested to initial next to citation AF, sign the form and return a copy of same to the undersigned.

Since the application has been allowed, this matter is somewhat urgent. If the Examiner has any questions regarding this Communication, such questions can be addressed by telephone to the undersigned.

Respectfully submitted,

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